

RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: *Pai, et al.*

Docket No.: TSM03-0146

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Serial No.: 10/662,609

Art Unit: 2814

MAR 13 2006

Filed: September 15, 2003

Examiner: Le, Thao X.

For: Dual Poly Layer And Method Of Manufacture

Mail Stop: After Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Pls  
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TL

Applicants respectfully submit the following remarks in response to Examiner's Office Action dated January 12, 2006, which Action is made final. Applicants respectfully request that these remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claims 24-33.

TSM03-0146

Page 1 of 5

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Pls  
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Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated August 9, 2006, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claims 24-43.